JFW/93B

03500.015809.

## PATENT APPLICATION

OFFI	Application of:		
re re	Application of:	)	
	·	:	Examiner: P. J. Macchiarolo
KAZUSHI NOMURA		)	
		:	Group Art Unit: 2875
Application No.: 09/955,137		)	•
		:	
Filed: September 19, 2001		)	
	•	:	
For:	ELECTRON-EMITTING DEVICE,	)	
	ELECTRON SOURCE, IMAGE	:	
	FORMING APPARATUS, AND	)	
	ELECTRON-EMITTING	:	
	APPARATUS	)	October 4, 2004
		,	•

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## THIRD INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the documents listed and a copy of a Japanese Official Letter citing these documents are enclosed. The Japanese Official Letter was issued in a foreign counterpart application.

10/06/2004 RFEKADU1 00000061 09955137 01 FC:1806

180.00 OP

Document JP 5-274997, which is cited in the Japanese Official Letter, is not listed on the Form PTO-1449, because that document is already of record. However, a further copy of that document is submitted herewith merely for the Examiner's convenience in interpreting the Japanese Official Letter, which, as pointed out below, cites a particular portion of the document.

Applicant represents that the Japanese Official Letter states, in a section that has been marked ① for the Examiner's convenience, the following:

\*①

"The reason for rejection 2:

The present invention as defined in the claims can be readily deduced by those skilled in the art in view of a technique described in the following documents published before the filing of the present application.

Cited References

Reference 1: JP 05-152640 Reference 2: JP 05-274997 Reference 3: JP 08-264107

Claims 1-9 have been rejected in view of the References 1 and 2.

Note:

The reference 1 discloses, in particular, in paragraphs [0038] - [0040] and Figs. 6-7, and the Reference 2 discloses, in particular, in paragraph [0019], an electron-emitting device wherein a first electrode, a second electrode and an electron-emitting film are disposed so that a height increases in order atop of a substrate, the first electrode, the electron-emitting film and the second electrode. And, the Reference 3 discloses an electron-emitting device with an anode disposed at atop of the device, and a flat display apparatus comprising the electron-emitting device.

All of the three References relate to the electron-emitting device. Accordingly, based on a suitable combination of techniques disclosed in the References 1-3, addition of a well-known technique, and a design change, the present invention defined in claims 1-9 can be readily deduced by those skilled in the art."

Paragraphs [0038] - [0040] of "reference 1" and [0019] of "reference 2" are marked with ② and ③, respectively, in the attached copies of those references, and English translations of those paragraphs also are attached to the corresponding references.

For the concise statement of relevance of non-English document 08-264107, the Examiner is respectfully referred to the English abstract attached thereto.

For the concise statement of relevance of non-English document 05-152640, the Examiner is respectfully referred to the English abstract attached thereto, and to English counterparts U.S. Patent 5,757,344 and GB 2 260 641 A, submitted herewith merely to supply a concise statement of relevance.

Lastly, for the concise statement of relevance of non-English document 05-274997, of record, the Examiner is respectfully referred to English counterpart U.S. Patent 5,612,587, submitted herewith merely to supply a concise statement of relevance.

For each non-English document, the Examiner also is referred to the above

English translation of part of the Japanese Official Letter, and the attached English translations of
the relevant paragraphs referred to above.

## STATEMENT UNDER 37 C.F.R. § 1.97(e)

Each item (document 08-264107 and 05-152640) of information cited in this information disclosure statement was first cited in any communication from a foreign Patent Office in a counterpart foreign application not more than three months prior to the filing date of this Statement.

A check in the amount of \$180.00 is enclosed.

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicant's undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

Attorney for Applicants

Registration No.: 42,476

FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza New York, New York 10112-3800

Facsimile: (212) 218-2200

NY\_MAIN 456135v1

FORM PTO 1449 (modified)				ATTY DOCKET NO. 03500.015809.		APPLICATION NO.	955,137			
U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE  LIST OF REFERENCES CITED BY APPLICANT(S)				APPLICANT  KAZUSHI NOMURA						
OCT 0 5 2004			FILING DATE SEPTEMBER 19, 200	GROUP	GROUP <b>2875</b>					
Es.	et T			U.S. PATENT DOCUMENTS						
EXAMPLE INITIAL	DOCUMENT NUMBER DATE		NAME CL		SS SUBCLASS	FILING DATE				
					-					
					+					
					-					
<u> </u>			FO'	REIGN PATENT DOCUMENTS	<del></del>					
•		DOCUMENT NUMBER	DATE	COUNTRY	CLAS	SS SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT			
		08-264107	10/11/96	JAPAN	H01	IJ 1/30	Abstract			
		05-152640	06/18/93	JAPAN	H01	IL 49/00	Abstract USP 5,757,344 and GB 2 260 641 A			
					-					
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)										
	-				<del>-</del>					
EYAMINED				DATE CONCIDENCE						

<sup>\*</sup>EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.